

| Search Notes  | Application/Control No. | Applicant(s)/Patent under Reexamination |
|---|-------------------------|---|
|  | 10/062,593              | AGRAWAL ET AL.                          |
|   | Examiner                | Art Unit                                |
|   | Jung Park               | 2661                                    |

| INTERFERENCE SEARCHED |          |      |          |
|-----------------------|----------|------|----------|
| Class                 | Subclass | Date | Examiner |
|                       |          |      |          |
|                       |          |      |          |
|                       |          |      |          |
|                       |          |      |          |
|                       |          |      |          |